

IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Chen et al.

Confirmation No.: 1660

Application No.: 10/085,866

Examiner: Hu, Shouxiang

Filing Date: Feb. 27, 2002

Group Art Unit: 2811

Title: EMISSION LAYER FORMED BY RAPID THERMAL FORMATION PROCESS

Mail Stop Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

Transmitted herewith is/are the following in the above-identified application:

- (X) Response/Amendment ( ) Petition to extend time to respond  
( ) New fee as calculated below ( ) Supplemental Declaration  
( ) No additional fee  
( ) Other: \_\_\_\_\_ (fee \$ \_\_\_\_\_)

CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY						
(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONAL FEES
TOTAL CLAIMS	30	MINUS	30	= 0	X \$18	\$ 0
INDEP. CLAIMS	3	MINUS	3	= 0	X \$86	\$ 0
[ ] FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					+ \$280	\$ 0
EXTENSION FEE	1ST MONTH \$110.00	2ND MONTH \$420.00	3RD MONTH \$950.00	4TH MONTH \$1480.00		\$ 0
OTHER FEES						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0

Charge \$ 0 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16 through 1.21 inclusive, and any other sections in Title 37 of the Code of Federal Regulations that may regulate fees. A duplicate copy of this sheet is enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.

Respectfully submitted,

Chen et al.

By 

Steven P. Fallon

Attorney/Agent for Applicant(s)  
Reg. No. 35,132

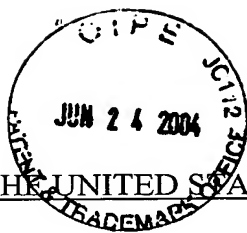
Date of Deposit: June 21, 2004

Typed Name: Steven P. Fallon

Signature: 

Date: June 21, 2004

10013802-1



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chen et al. )  
Serial No.: 10/085,866 )  
Conf. No.: 1660 )  
Filed: February 27, 2002 )  
For: EMISSION LAYER FORMED )  
BY RAPID THERMAL )  
FORMATION PROCESS )  
Art Unit: 2811 )  
Examiner: Hu, Shouxiang )

*I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.*

6/21/04

Date . Registration No. 3513  
F-CLASS.WCM  
Appr. February 20, 1998 Attorney for Applicant

**RESPONSE B TO OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir,

Please consider the following remarks in response to the office action mailed on April 2, 2004.